



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q62494

Ryo KUBOTO, et al.

Appln. No.: 09/817,233

Group Art Unit: 2823

Confirmation No.: 8072

Examiner: Hsien Ming Lee

Filed: March 27, 2001

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE HAVING DRAM CAPACITORS

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 30, 2005, please amend the above-identified application as follows on the accompanying pages.

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